



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidehiko KIRA, et al.**

Group Art Unit: **2822**

Serial No.: **08/897,953**

Examiner: **David E. GRAYBILL**

Filed: **July 24, 1997**

P.T.O. Confirmation No.: **5157**

For: **METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 11, 2007

Sir:

In response to the Office Action dated January 11, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.